



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Tetsuhiro Iwai et al.
Serial No.: 10/621,497 Art Unit: 1724
Filing Date: July 17, 2003
Title: "PLASMA PROCESSING APPARATUS AND PLASMA PROCESSING METHOD"
Docket No.: 35908

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, Va. 22313-1450

Sir/Madam:

In accordance with Rule 56, applicants are aware of the publications listed in the International Search Report (copy enclosed) and in the enclosed copy of Patent Office Form 1449. A copy of each of the publications is enclosed herewith.

Respectfully submitted,
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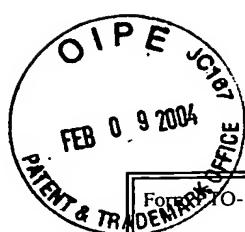
February 6, 2004

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner of Patents, P.O. Box 1450, Alexandria, Va. 22313-1450 on the date indicated below.

Jeffrey J. Sopko
Name of Attorney for Applicants

02/06/2004
Date

Signature of Attorney



Formerly TO-1449	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. 35908	SERIAL NO. 10/621,497
INFORMATION DISCLOSURE CITATION BY APPLICANT <i>(USE SEVERAL SHEETS IF NECESSARY)</i>		APPLICANT: Tetsuhiro Iwai et al.		
		FILING DATE: July 17, 2003	GROUP ART UNIT: 1724	

U.S. PATENT DOCUMENTS

Examiner Initial		Document No.	Date	Name	Class	Subclass	Filing Date if Appropriate
	A	5,792,376	08/1998	Kanai et al.			
	B	6,254,683 B1	07/2001	Matsuda et al.			
	C						
	D						
	E						
	F						
	G						
	H						
	I						
	J						
	K						

FOREIGN PATENT DOCUMENTS

		Document No.	Date	Country	Class	Subclass	Translation
	L						
	M						
	N						
	P						
	Q						

OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)

R	
S	
T	

Examiner:	Date Considered
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*Examiner: Initial if reference considered, regardless of whether citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.